## Western University Department of Mechanical & Materials Engineering

## MME 4482A - "Fundamentals of MEMS"

## **COURSE OUTLINE – 2020-2021**

CALENDAR DESCRIPTION: COURSE INFORMATION:	The objective of th (Microelectromechanica packaging, testing and r Instructor: D R Lectures: W 31 Tutorials: T	e cou al Sys eliabili or. Jun oom: S mail: j Vednes :30-4:3 BA	urse is to cover the tems) including design ity concerns. Yang SEB 3089 yang@eng.uwo.ca day 2:30-4:30 PM (SEB 2 0 PM (SEB 2099)	e fun a, ana 2200),	idamental basis of M alysis, modeling, fabric Thursday	AEMS cation,
PREREQUISITES:	Completion of third year of the Mechanical and Materials Engineering program, Integrated Engineering program or Electrical Engineering program. Unless you have either the requisites for this course or written special permission from your Dean to enroll in it, you will be removed from this course and it will be deleted from your record. This decision may not be appealed. You will receive no adjustment to your fees in the event that you are dropped from a course for failing to have the necessary prerequisites.					
ACCREDITATION UNITS:	Engineering Science = 3	35%, E	ngineering Design = 65%	6		
TOPICS:	<ol> <li>Course Overview, Ir</li> <li>Scale effects at micr</li> <li>Photolithography</li> <li>Thin film technologi</li> <li>Surface micromachii</li> <li>Bulk micromachinin</li> <li>Soft-lithography</li> <li>Packaging and testin</li> <li>MEMS applications</li> </ol>	ntroduc oscale: ies ning ig	etion to MEMS s			
LEARNING OUTCOMES:	<ul> <li>Upon successful competition of this course, student will</li> <li>1. learn clean room processes,</li> <li>2. learn microfabrication technologies,</li> <li>3. learn testing tools for MEMS devices,</li> <li>4. be able to design MEMS devices using numerical simulation and/or suitable software, and design associated microfabrication processes,</li> <li>5. be able to apply MEMS concept to develop new MEMS applications.</li> </ul>					
GENERAL LEARNING	Knowledge Base	X	Individual Work	X	Ethics and Equity	
UBJECTIVES:	Problem Analysis	X	Team Work		Economics and Project Management	
	Investigation	Х	Communication	X	Life-Long Learning	Х
	Design	X	Professionalism			
	Engineering Tools	X	Impact on Society	X		

CONTACT HOURS:	3 lecture hours, 3 tutorial hours, half course				
TEXT: (Recommended)	1. Mohamed Gad-el-Hak, The MEMS handbook, Second Edition, London, CRC Press c2006				
	<ol> <li>M. Madou, Fundamentals of Microfabrication and Nanotechnology, Third Edition, New York: CRC Press, 2011.</li> <li>Chang Liu, Foundations of MEMS, Pearson Education, NJ, 2006</li> </ol>				
REFERENCES:	Research papers, instructor to suggest.				
COMPUTING:	Basic programming skills will be advantageous. Some problems may be formulated for numerical solution. Available software packages include: ANSYS COMSOL AutoCAD, SolidWorks or any other CAD software				
UNITS:	S.I.				
EVALUATION:	The final grade is computed as follows: The course grade will be determined on homework assignments, exams/term test, presentations and project report.				
	Homework assignments20%Assigned week of Sep. 21, 2020				
	Term test 30% Week of Nov. 23, 2020 Open book exam				
	Term Project and Presentation50%Presentation: the weeks of Nov. 23 and Nov. 30, 2020Project reportDue: Dec. 10, 2020				
ENGLISH:	In accordance with Senate and Faculty Policy, students may be penalized up to 10% of the marks on all assignments, tests and examinations for the improper use of English. Additionally, poorly written work with the exception of final examinations may be returned without grading. If resubmission of the work is permitted, it may be graded with marks deducted for poor English and/or late submission.				
ATTENDANCE:	Any student who, in the opinion of the instructor, is absent too frequently from class or laboratory periods in any course, will be reported to the Dean (after due warning has been given). On the recommendation of the Department concerned, and with the permission of the Dean, the student will be debarred from taking the regular examination in the course.				
CHEATING:	University policy states that cheating, including plagiarism, is a scholastic offense. The commission of a scholastic offence is attended by academic penalties which might include expulsion from the program. If you are caught cheating, there will be no second warning. (see Scholastic Offence Policy in the Western Academic Calendar).				
SSD:	Please contact the course instructor if you require material in an alternate format or if any other arrangements can make this course more accessible to you. You may also wish to contact Services for Students with Disabilities (SSD) at 661-2111 x 82147 for any specific question regarding an accommodation				
NOTE:	The above topics and outline are subject to adjustments and changes as needed. Students who have failed an Engineering course (ie.<50%) must repeat all components of the				

course. No special permissions will be granted enabling a student to retain laboratory, assignment or test marks from previous years. Previously completed assignments and laboratories cannot be resubmitted for grading by the student in subsequent years.